

OCT 16 2006

Patent

Customer No.: 31561

Docket No. 13137-US-PA

Application No.: 10/710,844

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Applicant : Kuo, Cheng Chang

Application No. : 10/710,844

Filed : August 6, 2004

For : LOW-TEMPERATURE POLYSILICON THIN FILM
TRANSISTOR AND FABRICATION METHOD THEREOF

Art Unit : 2826

Examiner : ERDEM, FAZLI

TRANSMITTAL LETTER

+1-571-273-8300 (Via Fax: 2+8 pages)

Assistant Commissioner for Patents
Alexandria, VA 22314

Dear Sir,

In response to the Office Action dated July 17, 2006 (Paper No.: 07062006), transmitted herewith please find the Response in (8) pages.

The Applicant is NOT entitled to a status as a Small Entity; accordingly, please charge the following fees to the Deposit Account No.: 50-2620 (Order No.: 13137-US-PA),

Fees are calculated as follows:

<input type="checkbox"/> Extra Claims Fee :						
	NUMBER FILED	CLAIMS FILED HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	FEE	
Total Claims	4	MINUS 19	= 2	× \$ 50	= \$ 0	
Independent Claims	1	MINUS 3	= 0	× \$ 200	= \$ 0/	
					= \$ 0/ 120/ 450/ 1020	
<input type="checkbox"/> [1/2/3] month(s) extension of time is hereby requested.					= \$ 0/ 130	
<input type="checkbox"/> Terminal Disclaimer Fee					= \$ 0/ 180	
<input type="checkbox"/> Fee regarding Submission of an Information Disclosure Statement .					= \$ 0	
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If the payment is not fully covered in response thereof, the Commissioner is authorized to charge any fees required in connection with the filing of this paper to account No.: 50-2620 (Order No.: 13137-US-PA).

Patent

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Application No.: 10/710,844

Thank you for your assistance in the subject matter. If you have any questions, please feel free to contact me.

Respectfully Submitted,
JIANQ CHYUN Intellectual Property Office

Date: Oct. 16, 2006

By: Belinda Lee
Belinda Lee
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Examiner: ERDEM, FAZLI

Group Art Unit: 2826

In re PATENT APPLICATION of
Applicants : KUO, CHENG-CHANG

Serial No. : 10/710,844

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THEREOFAMENDMENT) Attorney Docket: 13137-US-PA
)

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AMENDMENT AND RESPONSE TO OFFICE ACTION

United States Patent and Trademark Office
Customer Service Window
Mail Stop Amendment
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Dear Sir:

The Office Action mailed on July 17, 2006, has been carefully considered. In response thereto, please consider the remarks.

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